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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF THE APPLICATION FOR PATENT

INVENTOR: Kazuhiro FUJIKAWA et al. | DOCKET NO.: 4858

APPLICATION NO.: 10/528,440 | CONFIRM. NO.: 4308

FILING DATE: March 18, 2005 | ART UNIT: 2818

TITLE OF INVENTION: | EXAMINER: T. P. LE
Method of Fabricating
Semiconductor Device

MS AF
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

November 20, 2007

please enter
Thanks
T. Le

RESPONSE TO THE FINAL OFFICE ACTION OF AUGUST 22, 2007, INCLUDING
AN ATTACHED COVER SHEET WITH CERTIFICATE OF TELEFAX TRANSMISSION

Dear Sir:

Please amend the above identified application as follows.

[RESPONSE CONTINUES ON NEXT PAGE]

*pls. ENTER the
amendment after final!*

Thanks

4858/WFF:he

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